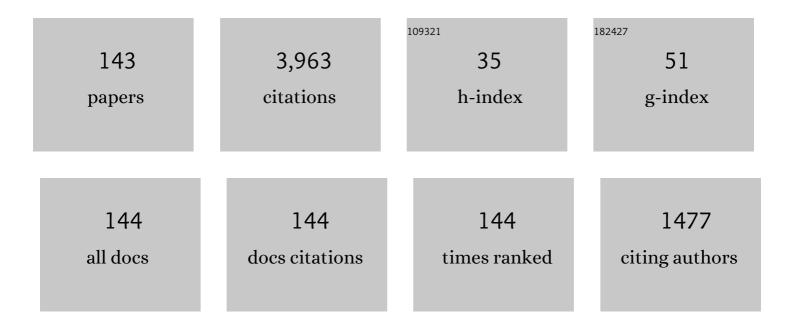
List of Publications by Year in descending order

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#	Article	IF	CITATIONS
1	Dielectric properties, electric modulus and conductivity profiles of Al/Al2O3/p-Si type MOS capacitor in large frequency and bias interval. Engineering Science and Technology, an International Journal, 2022, 27, 101017.	3.2	10
2	Dielectric Properties of PVP: BaTiO3 Interlayer in the Al/PVP: BaTiO3/P-Si Structure. Silicon, 2022, 14, 5437-5443.	3.3	12
3	High Dielectric Performance of Heterojunction Structures Based on Spin-Coated Graphene-PVP Thin Film on Silicon With Gold Contacts for Organic Electronics. IEEE Transactions on Electron Devices, 2022, 69, 304-310.	3.0	10
4	Identification of Current Transport Mechanisms and Temperature Sensing Qualifications for Al/(ZnS-PVA)/p-Si Structures at Low and Moderate Temperatures. IEEE Sensors Journal, 2022, 22, 99-106.	4.7	18
5	A comparison of Au/n-Si Schottky diodes (SDs) with/without a nanographite (NG) interfacial layer by considering interlayer, surface states (N _{ss}) and series resistance (R _s) effects. Physica Scripta, 2022, 97, 055811.	2.5	17
6	The illumination effects on the current conduction mechanisms of the Au/(<scp>Er₂O₃</scp> : <scp>PVC</scp>)/ <scp>n‣i</scp> (<scp>MPS</scp>) Schottky diodes. Journal of Applied Polymer Science, 2022, 139, .	2.6	19
7	Discrepancies in barrier heights obtained from current–voltage (IV) and capacitance–voltage (CV) of Au/PNoMPhPPy/n-GaAs structures in wide range of temperature. Journal of Materials Science: Materials in Electronics, 2022, 33, 12210-12223.	2.2	17
8	Dielectric properties and negative-capacitance/dielectric in Au/n-Si structures with PVC and (PVC:Sm2O3) interlayer. Materials Science in Semiconductor Processing, 2022, 147, 106754.	4.0	13
9	The effect of cadmium impurities in the (PVP–TeO2) interlayer in Al/p-Si (MS) Schottky barrier diodes (SBDs): Exploring its electrophysical parameters. Physica B: Condensed Matter, 2021, 604, 412617.	2.7	18
10	Current transport properties of (Au/Ni)/HfAlO3/n-Si metal–insulator–semiconductor junction. Journal of Physics and Chemistry of Solids, 2021, 148, 109758.	4.0	23
11	Frequency Response of C–V and G/ï‰-V Characteristics of Au/(Nanographite-doped PVP)/n-Si Structures. Journal of Materials Science: Materials in Electronics, 2021, 32, 993-1006.	2.2	20
12	Investigation of the variation of dielectric properties by applying frequency and voltage to Al/(CdS-PVA)/p-Si structures. Journal of Molecular Structure, 2021, 1224, 129325.	3.6	24
13	Electrical characterizationÂof Au/n-Si (MS) diode with and without graphene-polyvinylpyrrolidone (Gr-PVP) interface layer. Journal of Materials Science: Materials in Electronics, 2021, 32, 3451-3459.	2.2	19
14	Frequency dependence of the dielectric properties of Au/(NG:PVP)/n-Si structures. Journal of Materials Science: Materials in Electronics, 2021, 32, 7657-7670.	2.2	25
15	Evaluation of gamma-irradiation effects on the electrical properties of Al/(ZnO-PVA)/p-Si type Schottky diodes using current-voltage measurements. Radiation Physics and Chemistry, 2021, 183, 109430.	2.8	29
16	Illumination and voltage effects on the forward and reverse bias current–voltage (I-V) characteristics in In/In2S3/p-Si photodiodes. Journal of Materials Science: Materials in Electronics, 2021, 32, 21825-21836.	2.2	21
17	Effect of (Co–TeO2-doped polyvinylpyrrolidone) organic interlayer on the electrophysical characteristics of Al/p-Si (MS) structures. Journal of Materials Science: Materials in Electronics, 2021, 32, 21909-21922.	2.2	16

A comparison of electrical characteristics of Au/n-Si (MS) structures with PVC and (PVC:) Tj ETQq0 0 0 rgBT /Overlock 10 Tf 50.62 Td (Sr 35^{10} Sr 35^{10}

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19	Graphene doped (Bi2Te3–Bi2O3–TeO2): PVP dielectrics in metal–semiconductor structures. Applied Physics A: Materials Science and Processing, 2021, 127, 1.	2.3	11
20	Comparison of dielectric characteristics for metal–semiconductor structures fabricated with different interlayers thicknesses. Journal of Materials Science: Materials in Electronics, 2021, 32, 26700-26708.	2.2	3
21	Frequency Response of Metal–Semiconductor Structures With Thin-Films Sapphire Interlayer by ALD Technique. IEEE Transactions on Electron Devices, 2021, 68, 5085-5089.	3.0	11
22	Comparison of the electrical and impedance properties of Au/(ZnOMn:PVP)/n-Si (MPS) type Schottky-diodes (SDs) before and after gamma-irradiation. Physica Scripta, 2021, 96, 125881.	2.5	20
23	Comparison of electrical properties of MS and MPS type diode in respect of (In2O3-PVP) interlayer. Physica B: Condensed Matter, 2020, 576, 411733.	2.7	46
24	Frequency and voltage dependence of barrier height, surface states, and series resistance in Al/Al2O3/p-Si structures in wide range frequency and voltage. Physica B: Condensed Matter, 2020, 582, 411979.	2.7	51
25	Effect of illumination on electrical parameters of Au/(P3DMTFT)/n-GaAs Schottky barrier diodes. Indian Journal of Physics, 2020, 94, 1901-1908.	1.8	25
26	Identifying of series resistance and interface states on rhenium/n-GaAs structures using C–V–T and G/ω–V–T characteristics in frequency ranged 50ÂkHz to 5ÂMHz. Journal of Materials Science: Materials in Electronics, 2020, 31, 704-713.	2.2	5
27	The effects of (Bi2Te3–Bi2O3-TeO2-PVP) interfacial film on the dielectric and electrical features of Al/p-Si (MS) Schottky barrier diodes (SBDs). Physica B: Condensed Matter, 2020, 582, 411958.	2.7	33
28	Electrical and dielectric properties of Al/(PVP: Zn-TeO2)/p-Si heterojunction structures using current–voltage (l–V) and impedance-frequency (Z–f) measurements. Applied Physics A: Materials Science and Processing, 2020, 126, 1.	2.3	33
29	Electrical characteristics of Au/PVP/n-Si structures using admittance measurements between 1 and 500ÂkHz. Journal of Materials Science: Materials in Electronics, 2020, 31, 13337-13343.	2.2	7
30	Electric and dielectric parameters in Au/n-Si (MS) capacitors with metal oxide-polymer interlayer as function of frequency and voltage. Journal of Materials Science: Materials in Electronics, 2020, 31, 15589-15598.	2.2	26
31	Investigation of effects on dielectric properties of different doping concentrations of Au/Gr-PVA/p-Si structures at 0.1 and 1ÂMHz at room temperature. Journal of Materials Science: Materials in Electronics, 2020, 31, 16324-16331.	2.2	3
32	A comparison study regarding Al/p-Si and Al/(carbon nanofiber–PVP)/p-Si diodes: current/impedance–voltage (I/Z–V) characteristics. Applied Physics A: Materials Science and Processing, 2020, 126, 1.	2.3	13
33	A Highly Sensitive Temperature Sensor Based on Au/Graphene-PVP/ <i>n</i> -Si Type Schottky Diodes and the Possible Conduction Mechanisms in the Wide Range Temperatures. IEEE Sensors Journal, 2020, 20, 14081-14089.	4.7	37
34	A comparative study on the electrical properties and conduction mechanisms of Au/n-Si Schottky diodes with/without an organic interlayer. Journal of Materials Science: Materials in Electronics, 2020, 31, 14466-14477.	2.2	32
35	The possible current-conduction mechanism in the Au/(CoSO4-PVP)/n-Si junctions. Journal of Materials Science: Materials in Electronics, 2020, 31, 18640-18648.	2.2	11
36	On the electrical characteristics of Al/p-Si diodes with and without (PVP: Sn-TeO2) interlayer using current–voltage (l–V) measurements. Applied Physics A: Materials Science and Processing, 2020, 126, 1.	2.3	14

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37	Frequency and voltage dependence of electrical and dielectric properties in metal-interfacial layer-semiconductor (MIS) type structures. Physica B: Condensed Matter, 2020, 587, 412122.	2.7	36
38	Intersection behavior of the current–voltage (l–V) characteristics of the (Au/Ni)/HfAlO3/n-Si (MIS) structure depends on the lighting intensity. Journal of Materials Science: Materials in Electronics, 2020, 31, 13167-13172.	2.2	9
39	On the frequency and voltage-dependent main electrical parameters of the Au/ZnO/n-GaAs structures at room temperature by using various methods. Physica B: Condensed Matter, 2020, 594, 412274.	2.7	23
40	The origin of anomalous peak and negative capacitance on dielectric behavior in the accumulation region in Au/(0.07 Zn-doped polyvinyl alcohol)/n-4H–SiC metal-polymer-semiconductor structures/diodes studied by temperature-dependent impedance measurements. Journal of Physics and Chemistry of Solids, 2020, 144, 109523.	4.0	26
41	Investigation of the effect of different Bi2O3–x:PVA (x = Sm, Sn, Mo) thin insulator interface-layer materials on diode parameters. Journal of Materials Science: Materials in Electronics, 2020, 31, 8033-8042.	2.2	9
42	Frequency-Dependent Admittance Analysis of Au/n-Si Structure with CoSO4-PVP Interfacial Layer. Journal of Electronic Materials, 2020, 49, 3720-3727.	2.2	26
43	Investigation of gamma-irradiation effects on electrical characteristics of Al/(ZnO–PVA)/p-Si Schottky diodes using capacitance and conductance measurements. Journal of Materials Science: Materials in Electronics, 2020, 31, 8349-8358.	2.2	14
44	The interfacial properties of Au/n-4H-SiC structure with (Zn-doped PVA) interfacial layer. Physica Scripta, 2020, 95, 115809.	2.5	4
45	Investigation of Dielectric Properties, Electric Modulus and Conductivity of the Au/Zn-Doped PVA/ <i>n</i> -4H-SiC (MPS) Structure Using Impedance Spectroscopy Method. Zeitschrift Fur Physikalische Chemie, 2020, 234, 505-516.	2.8	5
46	Dielectric properties of \$\$hbox {Ag/Ru}_{0.03}\$\$–PVA/n-Si structures. Bulletin of Materials Science, 2019, 42, 1.	1.7	4
47	Dielectric characterization of BSA doped-PANI interlayered metal–semiconductor structures. Journal of Materials Science: Materials in Electronics, 2019, 30, 14224-14232.	2.2	15
48	Determination of current transport and trap states density in AlInGaN/GaN heterostructures. Microelectronics Reliability, 2019, 103, 113517.	1.7	15
49	Investigation of the efficiencies of the (SnO2-PVA) interlayer in Au/n-Si (MS) SDs on electrical characteristics at room temperature by comparison. Journal of Materials Science: Materials in Electronics, 2019, 30, 20479-20488.	2.2	23
50	Examination of dielectric response of Au/HgS-PVA/n-Si (MPS) structure by impedance spectroscopy method. Physica B: Condensed Matter, 2019, 566, 125-135.	2.7	39
51	Synthesis of boron and rare earth stabilized graphene doped polyvinylidene fluoride (PVDF) nanocomposite piezoelectric materials. Polymer Composites, 2019, 40, 3623-3633.	4.6	27
52	On the possible conduction mechanisms in Rhenium/n-GaAs Schottky barrier diodes fabricated by pulsed laser deposition in temperature range of 60–400ÂK. Journal of Materials Science: Materials in Electronics, 2019, 30, 9029-9037.	2.2	21
53	A comparison of electrical parameters of Au/n-Si and Au/(CoSO4–PVP)/n-Si structures (SBDs) to determine the effect of (CoSO4–PVP) organic interlayer at room temperature. Journal of Materials Science: Materials in Electronics, 2019, 30, 9273-9280.	2.2	36
54	The fabrication of Al/p-Si (MS) type photodiode with (%2 ZnO-doped CuO) interfacial layer by sol gel method and their electrical characteristics. Physica B: Condensed Matter, 2019, 560, 91-96.	2.7	39

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55	A comparative study on current/capacitance: voltage characteristics of Au/n-Si (MS) structures with and without PVP interlayer. Journal of Materials Science: Materials in Electronics, 2019, 30, 6491-6499.	2.2	32
56	Determination of Surface States Energy Density Distributions and Relaxation Times for a Metal-Polymer-Semiconductor Structure. IEEE Nanotechnology Magazine, 2019, 18, 1196-1199.	2.0	21
57	Thermal Annealing Effects on the Electrical and Structural Properties of Ni/Pt Schottky Contacts on the Quaternary AllnGaN Epilayer. Journal of Electronic Materials, 2019, 48, 887-897.	2.2	8
58	Frequency-Dependent Admittance Analysis of the Metal–Semiconductor Structure With an Interlayer of Zn-Doped Organic Polymer Nanocomposites. IEEE Transactions on Electron Devices, 2018, 65, 231-236.	3.0	38
59	Effects of a Thin Ru-Doped PVP Interface Layer on Electrical Behavior of Ag/n-Si Structures. Journal of Electronic Materials, 2018, 47, 3510-3520.	2.2	25
60	Preparation and characterization of cross-linked poly (vinyl alcohol)-graphene oxide nanocomposites as an interlayer for Schottky barrier diodes. International Journal of Modern Physics B, 2018, 32, 1750276.	2.0	8
61	Role of Graphene-Doped Organic/Polymer Nanocomposites on the Electronic Properties of Schottky Junction Structures for Photocell Applications. Journal of Electronic Materials, 2018, 47, 7134-7142.	2.2	17
62	Evaluation of Electric and Dielectric Properties of Metal–Semiconductor Structures With 2% GC-Doped-(Ca ₃ Co ₄ Ga _{0.001} O _{<i>x</i>}) Interlayer. IEEE Transactions on Electron Devices, 2018, 65, 3901-3908.	3.0	30
63	A comparative study on dielectric behaviours of Au/(Zn-doped PVA)/n-4H-SiC (MPS) structures with different interlayer thicknesses using impedance spectroscopy methods. Bulletin of Materials Science, 2018, 41, 1.	1.7	13
64	Preparation of (CuS–PVA) interlayer and the investigation their structural, morphological and optical properties and frequency dependent electrical characteristics of Au/(CuS–PVA)/n-Si (MPS) structures. Journal of Materials Science: Materials in Electronics, 2018, 29, 11801-11811.	2.2	19
65	Dielectric properties, electrical modulus and current transport mechanisms of Au/ZnO/n-Si structures. Progress in Natural Science: Materials International, 2018, 28, 325-331.	4.4	53
66	Effectuality of Barrier Height Inhomogeneity on the Current–Voltage–Temperature Characteristics of Metal Semiconductor Structures with CdZnO Interlayer. Journal of Electronic Materials, 2018, 47, 6059-6066.	2.2	46
67	Temperature and Interfacial Layer Effects on the Electrical and Dielectric Properties of Al/(CdS-PVA)/p-Si (MPS) Structures. Journal of Electronic Materials, 2018, 47, 6600-6606.	2.2	13
68	Preparation of mixed copper/PVA nanocomposites as an interface layer for fabrication of Al/Cu-PVA/p-Si Schottky structures. Physica B: Condensed Matter, 2018, 546, 93-98.	2.7	34
69	Determining electrical and dielectric parameters of Al/ZnS-PVA/p-Si (MPS) structures in wide range of temperature and voltage. Journal of Materials Science: Materials in Electronics, 2018, 29, 12735-12743.	2.2	11
70	Controlling the electrical characteristics of Au/nâ€Si structure with and without (biphenylâ€CoPc) and (OHSubsâ€ZnPc) interfacial layers at room temperature. Polymers for Advanced Technologies, 2017, 28, 952-957.	3.2	6
71	Investigation of photo-induced effect on electrical properties of Au/PPy/n-Si (MPS) type schottky barrier diodes. Journal of Materials Science: Materials in Electronics, 2017, 28, 6413-6420.	2.2	16
72	Investigation of frequency and voltage dependence surface states and series resistance profiles using admittance measurements in Al/p-Si with Co 3 O 4 -PVA interlayer structures. Physica B: Condensed Matter. 2017. 515. 28-33.	2.7	43

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73	Two-diode behavior in metal-ferroelectric-semiconductor structures with bismuth titanate interfacial layer. International Journal of Modern Physics B, 2017, 31, 1750197.	2.0	3
74	Electric and Dielectric Properties of Au/ZnS-PVA/n-Si (MPS) Structures in the Frequency Range of 10–200ÂkHz. Journal of Electronic Materials, 2017, 46, 4276-4286.	2.2	34
75	Investigation of the C-V characteristics that provides linearity in a large reverse bias region and the effects of series resistance, surface states and interlayer in Au/n-Si/Ag diodes. Journal of Alloys and Compounds, 2017, 708, 464-469.	5.5	22
76	On the Frequency and Voltage-Dependent Profiles of the Surface States and Series Resistance of Au/ZnO/n-Si Structures in a Wide Range of Frequency and Voltage. Journal of Electronic Materials, 2017, 46, 5728-5736.	2.2	34
77	Determining electrical and dielectric parameters of dependence as function of frequencies in Al/ZnS-PVA/p-Si (MPS) structures. Journal of Materials Science: Materials in Electronics, 2017, 28, 1315-1321.	2.2	38
78	Interfacial layer thickness dependent electrical characteristics of Au/(Zn-doped PVA)/ <i>n</i> -4H-SiC (MPS) structures at room temperature. EPJ Applied Physics, 2017, 80, 10101.	0.7	19
79	Frequency and voltage dependence dielectric properties, ac electrical conductivity and electric modulus profiles in Al/Co 3 O 4 -PVA/p-Si structures. Physica B: Condensed Matter, 2016, 500, 154-160.	2.7	54
80	Double exponential l–V characteristics and double Gaussian distribution of barrier heights in (Au/Ti)/Al2O3/n-GaAs (MIS)-type Schottky barrier diodes in wide temperature range. Applied Physics A: Materials Science and Processing, 2016, 122, 1.	2.3	57
81	Investigation of Electrical Characteristics in Al/CdS-PVA/p-Si (MPS) Structures Using Impedance Spectroscopy Method. IEEE Transactions on Electron Devices, 2016, 63, 2948-2955.	3.0	79
82	A Comparative Study on the Main Electrical Parameters of Au/ <l>n</l> -Si, Au/Biphenyl-CuPc/ <l>n</l> -Si/ and Au/Biphenylsubs-CoPc/ <l>n</l> -Si/ Type Schottky Barrier Diodes. Journal of Nanoelectronics and Optoelectronics, 2016, 11, 620-625.	0.5	5
83	Investigation of dielectric relaxation and ac electrical conductivity using impedance spectroscopy method in (AuZn)/TiO2/p-GaAs(110) schottky barrier diodes. Journal of Alloys and Compounds, 2015, 628, 442-449.	5.5	90
84	The source of negative capacitance and anomalous peak in the forward bias capacitance-voltage in Cr/p-si Schottky barrier diodes (SBDs). Materials Science in Semiconductor Processing, 2015, 39, 484-491.	4.0	74
85	Dielectric properties and electric modulus of Au/PPy/n-Si (MPS) type Schottky barrier diodes (SBDS) as a function of frequency and applied bias voltage. International Journal of Modern Physics B, 2015, 29, 1550075.	2.0	18
86	Dielectric spectroscopy studies and ac electrical conductivity on (AuZn)/TiO ₂ /p-GaAs(110) MIS structures. Philosophical Magazine, 2015, 95, 2885-2898.	1.6	33
87	Comparative study of the temperature-dependent dielectric properties of Au/PPy/n-Si (MPS)-type Schottky barrier diodes. Journal of the Korean Physical Society, 2015, 67, 889-895.	0.7	16
88	Electrical characteristics of Au/PVA (x-doped)/n-Si: Comparison study on the effect of dopant type in PVA. Fibers and Polymers, 2014, 15, 2253-2259.	2.1	2
89	Frequency and voltage-dependent electrical and dielectric properties of Al/Co-doped PVA/p-Si structures at room temperature. Chinese Physics B, 2014, 23, 047304.	1.4	37
90	Single Gaussian distribution of barrier height in Al/PS–ZnPc/p-Si type Schottky barrier diode in temperature range of 120–320ÂK. Journal of Materials Science: Materials in Electronics, 2014, 25, 4391-4397.	2.2	11

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#	Article	IF	CITATIONS
91	Electrical and dielectric properties and intersection behavior of G/ω-V plots for Al/Co-PVA/p-Si (MPS) structures at temperatures below room temperature. Journal of the Korean Physical Society, 2014, 65, 2082-2089.	0.7	20
92	Capacitance/Conductance–Voltage–Frequency Characteristics of \${m Au}/{m PVC}+{m TCNQ}/{m p}hbox{-}{m Si}\$ Structures in Wide Frequency Range. IEEE Transactions on Electron Devices, 2014, 61, 584-590.	3.0	28
93	Charge transport mechanisms and density of interface traps in MnZnO/p-Si diodes. Journal of Alloys and Compounds, 2014, 590, 157-161.	5.5	69
94	Dielectric and Optical Properties of CdS–Polymer Nanocomposites Prepared by the Successive Ionic Layer Adsorption and Reaction (SILAR) Method. Journal of Electronic Materials, 2014, 43, 1226-1231.	2.2	18
95	Investigation of currentâ€voltage characteristics and current conduction mechanisms in composites of polyvinyl alcohol and bismuth oxide. Polymer Engineering and Science, 2014, 54, 1811-1816.	3.1	8
96	Frequency and Voltage Dependence of Dielectric Loss of MgB2 Composites at Different Temperatures. Journal of Superconductivity and Novel Magnetism, 2013, 26, 2165-2170.	1.8	0
97	A study of polymer-derived erbia-doped Bi2O3 nanocrystalline ceramic powders. Journal of Sol-Gel Science and Technology, 2013, 66, 317-323.	2.4	1
98	The origin of negative capacitance in Au/n-GaAs Schottky barrier diodes (SBDs) prepared by photolithography technique in the wide frequency range. Current Applied Physics, 2013, 13, 1101-1108.	2.4	34
99	The effect of metal work function on the barrier height of metal/CdS/SnO2/In–Ga structures. Current Applied Physics, 2013, 13, 1306-1310.	2.4	15
100	A detailed comparative study on the main electrical parameters of Au/n-Si and Au/PVA:Zn/n-Si Schottky barrier diodes. Materials Science in Semiconductor Processing, 2013, 16, 1865-1872.	4.0	41
101	On the Voltage and Frequency Distribution of Dielectric Properties and ac Electrical Conductivity in Al/SiO ₂ /p-Si (MOS) Capacitors. Chinese Physics Letters, 2013, 30, 017301.	3.3	21
102	The Main Electrical and Interfacial Properties of Benzotriazole and Fluorene Based Organic Devices. Journal of Macromolecular Science - Pure and Applied Chemistry, 2013, 50, 168-174.	2.2	13
103	Analyses of temperature-dependent interface states, series resistances, and AC electrical conductivities of Al/p—Si and Al/Bi 4 Ti 3 O 12 /p—Si structures by using the admittance spectroscopy method. Chinese Physics B, 2013, 22, 108502.	1.4	12
104	On the energy distribution of interface states and their relaxation time profiles in Al/pentacene/p-GaAs heterojunction diode. Journal of Applied Physics, 2012, 111, 034508.	2.5	15
105	Effects of interface states and series resistance on electrical properties of Al/nanostructure CdO/p-GaAs diode. Journal of Alloys and Compounds, 2012, 541, 462-467.	5.5	37
106	Temperature dependent negative capacitance behavior of Al/rhodamine-101/n-GaAs Schottky barrier diodes and Rs effects on the C–V and G/ï‰â€"V characteristics. Journal of Alloys and Compounds, 2012, 513, 107-111.	5.5	53
107	The effects of temperature, radiation, and illumination on current–voltage characteristics of Au/PVA(Co, Znâ€doped)/n‣i Schottky diodes. Journal of Applied Polymer Science, 2012, 125, 1185-1192.	2.6	18
108	The effect of gamma irradiation on electrical and dielectric properties of Al-TiW-Pd2Si/n-Si Schottky diode at room temperature. Current Applied Physics, 2012, 12, 860-864.	2.4	9

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109	The effect of gamma irradiation on electrical and dielectric properties of organic-based Schottky barrier diodes (SBDs) at room temperature. Radiation Physics and Chemistry, 2012, 81, 362-369.	2.8	25
110	Structural and electrical characterization of rectifying behavior in n-type/intrinsic ZnO-based homojunctions. Materials Science and Engineering B: Solid-State Materials for Advanced Technology, 2012, 177, 588-593.	3.5	11
111	Illumination intensity effects on the dielectric properties of schottky devices with Co, Niâ€doped PVA nanofibers as an interfacial layer. Advances in Polymer Technology, 2012, 31, 63-70.	1.7	18
112	The forward bias current density–voltage–temperature (<i>J–V–T</i>) characteristics of Al–SiO ₂ –pSi (MIS) Schottky diodes. International Journal of Electronics, 2011, 98, 699-712.	1.4	3
113	The origin of anomalous peak and negative capacitance in the forward bias capacitance-voltage characteristics of Au/PVA/n-Si structures. Journal of Applied Physics, 2011, 109, .	2.5	87
114	On the mechanism of current-transport in Cu/CdS/SnO2/In–Ga structures. Journal of Alloys and Compounds, 2011, 509, 5555-5561.	5.5	45
115	Analysis of the forward and reverse bias <i>I-V</i> characteristics on Au/PVA:Zn/n-Si Schottky barrier diodes in the wide temperature range. Journal of Applied Physics, 2011, 109, .	2.5	48
116	Illumination Effect on Admittance Measurements of Polyvinyl Alcohol (Co, Zn-Doped)â^•n-Si Schottky Barrier Diodes in Wide Frequency and Applied Bias Voltage Range. , 2011, , .		1
117	Comparative Analysis of Temperature-Dependent Electrical and Dielectric Properties of an \$hbox{Al}{-}hbox{TiW}{-}hbox{Pd}_{2}hbox{Si/n-Si}\$ Schottky Device at Two Frequencies. IEEE Transactions on Electron Devices, 2011, 58, 4042-4048.	3.0	16
118	Electrical characterization of MS and MIS structures on AlGaN/AlN/GaN heterostructures. Microelectronics Reliability, 2011, 51, 370-375.	1.7	43
119	Preparation and dielectric properties of polyvinyl alcohol (Co, Zn Acetate) Fiber/n-Si and polyvinyl alcohol (Ni, Zn Acetate)/n-Si Schottky diodes. Fibers and Polymers, 2011, 12, 886-892.	2.1	11
120	Anomalous Peak in the Forward-Bias C–V Plot and Temperature-Dependent Behavior of Au/PVA (Ni,Zn-doped)/n-Si(111) Structures. Journal of Electronic Materials, 2011, 40, 157-164.	2.2	61
121	The illumination intensity and applied bias voltage on dielectric properties of au/polyvinyl alcohol (Co, Znâ€doped)/nâ€Si Schottky barrier diodes. Journal of Applied Polymer Science, 2011, 120, 322-328.	2.6	37
122	Temperature dependent current–voltage (l–V) characteristics of Au/n-Si (111) Schottky barrier diodes with PVA(Ni,Zn-doped) interfacial layer. Materials Science in Semiconductor Processing, 2011, 14, 139-145.	4.0	57
123	The role of 60Co γ-ray irradiation on the interface states and series resistance in MIS structures. Radiation Physics and Chemistry, 2010, 79, 457-461.	2.8	16
124	The effect of insulator layer thickness on the main electrical parameters in (Ni/Au)/AlxGa1â^'xN/AlN/GaN heterostructures. Surface and Interface Analysis, 2010, 42, 803-806.	1.8	3
125	Illumination effect on electrical characteristics of organic-based Schottky barrier diodes. Journal of Applied Physics, 2010, 108, .	2.5	27
126	Frequency and Temperature Dependence of Dielectric Properties of Au/Polyvinyl Alcohol (Co,) Tj ETQq0 0 0 rgBT	/Overlock 3.4	10 Tf 50 67 ⁻ 25

Biomaterials, 2010, 59, 739-756.

#	Article	IF	CITATIONS
127	The explanation of barrier height inhomogeneities in Au/n-Si Schottky barrier diodes with organic thin interfacial layer. Journal of Applied Physics, 2010, 108, .	2.5	87
128	Temperature dependent negative capacitance behavior in (Ni/Au)/AlGaN/AlN/GaN heterostructures. Journal of Non-Crystalline Solids, 2010, 356, 1006-1011.	3.1	70
129	The distribution of barrier heights in MIS type Schottky diodes from current–voltage–temperature (l–V–T) measurements. Journal of Alloys and Compounds, 2009, 479, 893-897.	5.5	67
130	Tunneling current via dislocations in Schottky diodes on AlInN/AlN/GaN heterostructures. Semiconductor Science and Technology, 2009, 24, 075003.	2.0	75
131	Dislocation-governed current-transport mechanism in (Ni/Au)–AlGaN/AlN/GaN heterostructures. Journal of Applied Physics, 2009, 105, .	2.5	89
132	Frequency and gate voltage effects on the dielectric properties of Au/SiO2/n-Si structures. Microelectronic Engineering, 2008, 85, 1910-1914.	2.4	55
133	Effects of γ-ray irradiation on the C–V and G/ï‰â€"V characteristics of Al/SiO2/p-Si (MIS) structures. Nuclear Instruments & Methods in Physics Research B, 2008, 266, 791-796.	1.4	15
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